

<b>Notice of References Cited</b>	Application/Control No. 10/649,050	Applicant(s)/Patent Under Reexamination CHEN ET AL	
	Examiner Chuong A. Luu	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,111,287	08-2000	Arai, Hajime	257/317
*	C	US-5,841,161	11-1998	Lim et al.	257/315
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	M	US-			

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**NON-PATENT DOCUMENTS**

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